



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

RECEIVED  
AUG 14 2003  
TC 1700

In re Application

Inventor: Jeffrey W. Carr  
Appln. No.: 10/002,035  
Confirm. No.: 5043  
Filed: November 1, 2001  
Title: APPARATUS AND METHOD  
FOR ATMOSPHERIC PRESSURE  
REACTIVE ATOM PLASMA  
PROCESSING FOR SHAPING  
OF DAMAGE FREE SURFACES

PATENT APPLICATION

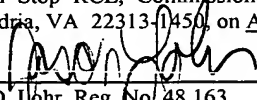
Art Unit: 1746  
Examiner: Allan W. Olsen

Customer No. 23910

#19B  
8/25/03  
mw

**CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8**

I hereby certify that this correspondence is being deposited in the United States Postal Service with sufficient postage as first class mail in an envelope addressed to Mail Stop RCE, Commissioner for Patents, Art Unit 1746, PO Box 1450, Alexandria, VA 22313-1450, on August 8, 2003.

  
Jason D. Lohr, Reg. No. 48,163  
Signature Date: August 8, 2003.

(Attorney Signature)

**RESPONSE "C" TO OFFICE ACTION UNDER 37 C.F.R. § 1.116**

Mail Stop RCE  
Commissioner for Patents  
Art Unit 1746  
PO Box 1450  
Alexandria, VA 22313-1450

Sir:

This RESPONSE "C" is in reply to the final Office Action mailed April 25, 2003. No additional fee is required with this response.

**Amendments**

Please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of the claims which begins on Page 2 of this paper.